

Application/Control	No
10/008,462	
Examiner	

Applicant(s)/Patent under Reexamination
STASZEWSKI ET AL.
Art Unit

Jean B. Corrielus

2637

SEARCHED				
Class	Subclass	Date	Examiner	
375	371;376	5/21/2005	JBC	
331	116FE			
327	105-107	•		
708	271		4	
331	2;108B			
	1A			
	56-57			
	34;36C			
	177R			
			•	

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEAR (INCLUDING SE	CH NOTES EARCH STRATEGY	·)
	DATE	EXMR
East	5/20/2005	JBC